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Enclosed herewith for filing is a patent application, as follows:

Inventor: Yun-Sang, Lee

Title: **Integrated Circuit Device Having An Internal State Monitoring Function**

X Return Receipt Postcard
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13 Pages Specification ☒ and Title page (not including claims)
2 Pages Claims
1 Page Abstract
5 Sheets of Drawings (Figs. 1, 2, 3, 4, 5, 6 and 7)
2 Pages Declaration For Patent Application and Power of Attorney (unsigned)
☒ Certified Copy of Korean Application No.: 99-41360, filed on September 27, 1999

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CLAIMS AS FILED

For	Number Filed		Number Extra		Rate		Basic Fee
Total Claims	4	-20 =	0	x	\$18.00	=	\$ 0.00
Independent Claims	4	-3 =	1	x	\$78.00	=	\$ 78.00
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application							\$
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☒ Total fee for filing the patent application in the amount of \$ 768.00

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Respectfully submitted,

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TITLE: INTEGRATED CIRCUIT DEVICE HAVING AN
INTERNAL STATE MONITORING FUNCTION

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PATENT SPECIFICATION TITLE PAGE

INTEGRATED CIRCUIT DEVICE HAVING AN INTERNAL STATE MONITORING FUNCTION

5 This application relies for priority upon Korean Patent Application No. 1999-41360, filed on September 27, 1999, the contents of which are herein incorporated by reference in their entirety.

Field of the Invention

10 The present invention is in the field of a semiconductor integrated circuit device and is more specifically related to a circuitry for monitoring an internal state of an integrated circuit device.

Background of the Invention

15 A probing equipment employed in testing semiconductor integrated circuits is constructed with a probing card that is a printed circuit board on which very fine needles are fixed. An electrical transmission from an integrated circuit to a test equipment which analyzes electrical information from the integrated circuit is accomplished by contacting the needles to
20 input/output pads of the integrated circuit. Electrical signals for testing are transferred to the test equipment through the probing means.

Otherwise, to perform a test function against internal signals of semiconductor integrated circuit such as dynamic random access memories, static random access memories, and non-volatile memories like read only
25 memories needs a more precise apparatus that is a micro probing equipment.

The micro probing equipment checks the internal signals being active in a low frequency and contacts probing needles to test pads through which signal lines in the semiconductor integrated circuit are connected to the test equipment.

5 However, there are several problems in such a micro probing device. First, the internal signals passing through the signal lines may not be transferred to the probing card or would be distorted from their original forms, because of parasitic loading factors existed in the probing needles, such as resistance, capacitance, and inductance. The second is that an area
10 occupied by test pads is becoming relatively larger in proportion to an increase an integration density of the semiconductor memory devices. The third demerit is that there would easily occur physical damages such as an injury of test pads, o r a snap-down of signal lines, because the needles on the probing card move in a tremble or other environments. And, a time for
15 preparing a test system to connect the micro probing apparatus to test equipment is longer than those of other test types, causing an increase of a whole test time. Those problems relevant to the probing apparatus for testing high density semiconductor memory devices are not helpful in promoting fail analysis and development of semiconductor integrated circuit
20 devices, thereby resulting in a degradation of manufacturing yield with them.

Summary of the Invention

The present invention is intended to solve the problems. And, it is an object of the invention to provide an integrated circuit device capable of a
25 test operation without using a probing device or pads exclusively used for

the test operation.

It is another object of the invention to provide an internal state monitoring circuit capable of enhancing reliability and efficiency for testing in a high density semiconductor integrated circuit device.

5 It is another object of the invention to provide an integrated circuit device having an internal state monitoring function without using a probing device or test pads.

It is another object of the invention to provide a method for monitoring internal states in a high density semiconductor integrated circuit device without using a probing device or test pads for testing.

10 In order to accomplish those objects, an integrated circuit device of the invention employs a selection circuit for controlling transfer paths of the internal signals and data from a sense amplifier, in response to selection signals. The selection signals correspond to test information signals. The
15 internal signals passing through the selection circuit are transferred to an outside of the device through a data output buffer and input/output pads. The invention makes an integrated circuit device be on need of using a probing apparatus and additional pads exclusive for testing.

It is preferred that an practical configuration of the integrated circuit
20 device includes: a plurality of internal circuits for generating a plurality of internal signals, the internal signals used for addressing storage locations and for controlling internal operations; a first selection circuit for receiving the internal circuits in response to selection signals corresponding to test information signals; a second selection circuit for receiving output signals
25 from the first selection circuit and output signals from a sense amplifier, and

for opening an alternative one of transfer paths of the internal signals and the output signals in response to the selection signals; and a data output buffer for transferring output signals from the second selection signals to an outside of the device through data input/output pads.

5 In monitoring internal signals in the integrated circuit device having sense amplifier, a data output buffer, and input/output pads, the sequential steps are performed by (1) detecting a test mode in response to a logical states with external control signals of the integrated circuit device; (2) selecting a part of internal signals of the integrated circuit device in response
10 to selection signals corresponding to test information signals; (3) selecting an alternative one of transfer paths of the part of the internal signals and output signals from the sense amplifier in response to the selection signals; and (4) transferring the part of the internal signals to an outside of the integrated circuit device through the data output buffer and the input/output
15 pads.

Brief Description of the Drawings

For a better understanding of the invention, and to show how embodiments of the same may be carried into effect, reference will now be
20 made, by way of example, to the accompanying diagrammatic drawings, in which:

Figure 1 is a block diagram of a semiconductor memory device employing an internal state monitoring function according to a preferred embodiment of the invention;

25 Figure 2 shows an architecture of the internal state monitoring circuit

shown in Figure 1;

Figure 3 is a circuit diagram of a test information input circuit;

Figure 4 is a circuit diagram of a first selection circuit shown in Figure 2;

Figure 5 is a circuit diagram of a second selection circuit shown in Figure 2;

Figure 6 is a circuit diagram of a data output buffer shown in Figure 2; and

Figure 7 is a timing diagram showing an operation for monitoring an internal state of the semiconductor memory device.

In the drawings referred to the present specification, the identical reference numerals denote the same or corresponding parts. And, the signals whose reference numerals has a suffix "B" is active in negative logic.

Detailed Description of Preferred Embodiments

Hereinbelow, applicable embodiments of the invention will be as follows, with the appended drawings. The present invention is embodied into a high density DRAM as an example.

Referring to Figure 1, a semiconductor integrated circuit associated to the present invention includes control logic block 10, data output buffer 90, test information input circuit 100, first selection circuit 110, and second selection circuit 120. Control logic block 10 generates test mode signal TMS in response to signals CSB, RASB, CASB, and WB those are control signals normally used in a DRAM. Test information input circuit 100 receives internal test information signals TSEL from address buffers, 20 and

30, and then generates plural selection signals SEL0~SELn-1 corresponding to test information signals TSEL in response to test mode signal TMS.

First selection circuit 110 selects transmission paths of first-stage internal signals INTS that are generated from internal circuit in the semiconductor integrated circuit, and makes a part of the internal signals INTS be transferred into the second selection circuit 120. Second selection circuit 120 applies one of the internal signals from first selection circuit 110 and data signals from the internal circuits to data output buffer 90, corresponding to the selection signals SEL0~SELn-1. Data output buffer 90 transfers data from sense amplifier 70 to input/output pads DQ during a normal operation mode, or transfers signals from the second selection circuit 120 receiving second-stage internal signals INTS' from first selection circuit 110 to input/output pads during a test mode. Row address buffer 20 and column address buffer 30 receives address signals Ai during the normal operation mode, while receiving external test information signals XTESL during the test mode. Row decoder 40 generates decoded row address signals DRA from the row address signals RA of the row address buffer 20 for the normal and test modes. Column decoder 50 generates decoded column address signals DCA from the column address signals CA of the column address buffer 30 for the normal and test modes.

Memory cell array 60 includes a plurality of memory cells coupled to a plurality of wordlines and bitlines. The memory cells store data D during the normal and test modes. Sense amplifier 70 transfers data supplied from data input buffer 80 into memory cell array 60, and transfers data stored in memory cell array 60 to data output buffer 90. It should be understood that

the internal signals INTS includes a multiplicity of signals in addition to row address signals RA, column address signals CA, control signals CON, and decoded address signals DRA and DCA.

Figure 2 shows a interconnecting features between first selection circuit 110, second selection circuit 120, and data output buffer 90. First selection circuit is formed of a plurality of groups each of which consists of selection units 111~114 which receive first-stage internal signals INTS0~INTS3, and generates second-stage internal signals INTS0'~INTS3', respectively. One of the selection unit groups is corresponding to one of selection signals SEL0~SELn-1 generated from test information input circuit 100. In Figure 2, selection units 111~114 is n'th group and controlled by n'th selection signal SELn in common. Second selection circuit 120 is formed of a plurality of groups each of which consists of selection units 121~124 which receive second -stage internal signals INTS0'~INTS3' from first selection circuit 110, respectively. And, data bits D0~D3 from the sense amplifier 70 applied to selection units 121~124, respectively. As the first selection circuit does, selection units 121~124 is n'th group and controlled by n'th selection signal SELn-1 in common. Corresponding to the arrangement in first selection circuit 110 and second selection circuit 120, data output buffer 90 has a plurality of groups each of which consists of data output units 91~94 that receive signals from second selection circuit 120 and transfer data bits D0~D3 and third-stage internal signals INTS0''~INTS3'' to the input/output pads, in response to output enable signal OEB, respectively.

Test information input circuit 100, referring to Figure 3, is formed of a plurality of test information storage units 101 each receiving a plurality of

test information signals TSEL0~TSELn-1 and generating a plurality of selection signals SEL0~SELn-1. Each of storage units 101 has CMOS transmission gate TG1, latch LAT, and inverters I1~I3. Transmission gate TG controlled by test mode signal TMS. TSEL0 is applied to latch LAT through transmission gate TG1 when TMS is high level. The output of latch LAT is generated as selection signal SEL0 through inverters I2 and I3 connected in serial.

Selection unit 111, 112, 113, or 114, of first selection circuit 110, referring to Figure 4, is formed of transmission gate TG2 and inverters I4~I6.

Transmission gate TG2 is controlled by selection signal SEL. First-stage internal signal INTS passes through transmission gate TG2 when selection signal SEL is high level, and generated as second-stage internal signal INTS' through inverters I5 and I6 connected in serial. Selection unit 121, 122, 123, or 124, of second selection circuit 120, referring to Figure 5, includes

two transmission gates TG3 and TG4 which are controlled by selection signal SEL. Transmission gates TG3 and TG4 pass data bit D from the sense amplifier and second-stage internal signal INTS', respectively, in response to selection signal SEL. Transmission gates TG3 and TG4 are turned on when selection signal SEL is low and high levels, respectively.

Referring to Figure 6, in data output unit 91, 92, 93, or 94, of data output buffer 90, data bit D or second stage internal signal INTS' supplied from second selection circuit 120 is applied to inputs of NOR and NAND gates which are controlled by output enable signal OEB. Outputs from the NOR and NAND gates are applied to gates of output transistors NM1 and NM2 through inverter I10 and serial-connected inverters I11 and I12,

respectively. Alternative one of data bit D and internal signal INTS”, corresponding to the input of the data output unit, is generated at a node between output transistors NM1 and NM2.

Now, an explanation about an operation in the test mode will be given in conjunction with the timing chart of Figure 7. The DRAM shown in Figure 1 has a normal operation mode and a test operation mode. An operation of the normal mode will be described ahead of an explanation relevant to the test mode.

The normal mode is divided into a writing operation and a reading operation. First, in the writing operation, address signals Ai are applied to row and column address buffers, 20 and 30, in response to row address strobe signal RASB and column address strobe signal CASB, respectively. Address buffers 20 and 30 generate row address signals RA and column address signals CA, and apply them to row decoder 40 and column decoder 50, respectively. When write enable signal WEB is enabled, input data supplied through data input buffer 80 are applied to sense amplifier 70. Row decoder 40 and column decoder 50 generate decoded row and column address signals, DRA and DCA, respectively, in order to activate corresponding wordlines and bitlines in memory cell array 60. Then, the input data passing through sense amplifier 70 are stored in memory cells selected by the row and column addresses.

In the reading operation, after completing an addressing sequence for memory cells in memory cell array 60 as the writing operation does, data stored in selected memory cells are transferred into corresponding bitlines by sharing charges therebetween. Then, sense amplifier 70 detects voltages

on the bitlines and transfers the sensed data to data output buffer 90 through second selection circuit 120. Second selection circuit 120, referring to Figure 5, opens paths for the data from sense amplifier 70 while blocks paths for the internal signals because selection signals SEL are low levels. Data output buffer 90 transfers the data from sense amplifier 70 to the outside of the DRAM in response to output enable signal OEB.

The test operation is performed throughout several sequence steps of detecting a test mode, selecting a part of the internal signals in response to test mode signal TMS, and transferring the selected internal signals to the outside of the DRAM chip, as follows.

The test operation initiates when test mode signal TMS is enabled to high level in response all to the activated control signals, CSB, RASB, CASB, and WB, with low levels. Test mode signal TMS is applied to test information input circuit 100. Then, external test information signals XTSEL are converted into internal test information signals TSEL, with CMOS levels, through row and column address buffers, 20 and 30. TSEL are applied to test information input circuit 100. Test information input circuit 100 store the test information signals in latches LAT in response to the high-leveled test mode signal TMS, as shown in Figure 3, and generates selection signals SEL (SEL0~SELn-1) corresponding to test information signals TSEL. Selection signals SEL are applied to first and second selection circuits, 110 and 120.

And, next, first selection circuit 110 transfers a part of first-stage internal signals INTS (including row address signals RA, column address signals CA, control signals CON, decoded address signals, DRA and DCA,

and et al.) into second-stage internal signals INTS', in response to selection signals SEL. Assuming that, in Figures 2 and 4, internal signals INTS0~INTS3 are each RA, CA, CON, and DRA (referred to as RA~DRA), and selection signal SELn-1 are active with high levels, the four bits of the RA~DRA among all the internal signals applied to first selection circuit 110 will be transferred to as second-stage internal signals INTS' (INTS0'~INTS3', or RA'~DRA') applied to second selection circuit 120. Since selection signals SELn-1 are high levels, the internal signals RA~DRA selected through first selection circuit 110 are transferred to data output buffer 90 through second selection circuit 120. During that time, in the selection units responding to SELn-1 in second selection circuit 120, referring to Figure 5, transmission gate TG3 is shut off while transmission gate TG4 is turned on.

In data output buffer 90, the internal signals RA~DRA selected through first and second selection circuits, 110 and 120, are driven in their corresponding data output units (e.g., 91~94) and transferred to the outside of the DRAM chip as third-stage internal signals (i.e., finally test output signals to be monitored) through input/output pads DQ. The internal signals from input/output pads DQ are analyzed in a test device.

As described above, the present invention offers significant advantages over conventional art, in which the internal signals generated within the integrated memory circuit device (e.g., DRAM) are transferred to the outside of the integrated circuit device through the data output buffer and input/output pads those are also used in a normal operation mode, so that there are no needs for preparing additional pads only exclusive to a test

operation and a probing apparatus. Therefore, the integrated circuit device would be free from a burden of increased pads for testing, and from a degradation of test reliability with signal transmission due to the parasitic noise components and the physical damages. Furthermore, the invention
5 can reduce a testing time because of no preparing an interconnection between an integrated device and the probing apparatus.

While this invention has been described in connection with what is presently considered to be the most practical and preferred embodiment, specifically in a DRAM, it is to be understood that the invention is not
10 limited to the disclosed embodiment. Since other integrated circuit memory devices but the DRAM utilizes a multiplicity of internal signals including address signals, control signals, and et al, the monitoring configuration with the selection circuits and the data output buffers that is basically employed in all the memory devices would be arranged for testing by those skilled in
15 this art. And, it is intended to cover various modifications and equivalent arrangements included within the scope of the invention.

WHAT IS CLAIMED IS:

1. An integrated circuit device comprising:

a plurality of internal circuits for generating a plurality of internal
5 signals, the internal signals used for addressing storage locations and for
controlling internal operations;

a selection circuit for controlling transfer paths of the internal signals
and data in response to selection signals, the selection signals corresponding
to test information signals; and

10 a data output buffer for transferring the internal signals to an outside
of the device through data input/output pads.

2. An integrated circuit device comprising:

a plurality of internal circuits for generating a plurality of internal
15 signals, the internal signals used for addressing storage locations and for
controlling internal operations;

a first selection circuit for receiving the internal circuits in response
to selection signals corresponding to test information signals;

a second selection circuit for receiving output signals from the first
20 selection circuit and output signals from a sense amplifier, and for opening
an alternative one of transfer paths of the internal signals and the output
signals in response to the selection signals; and

a data output buffer for transferring output signals from the second
selection signals to an outside of the device through data input/output pads.

3. A method for monitoring internal signals in an integrated circuit device having input/output pads, the method comprising the steps of:
detecting a test mode;
selecting a part of internal signals of the integrated circuit device; and
5 transferring the part of the internal signals to an outside of the integrated circuit device through the input/output pads.

4. A method for monitoring internal signals in an integrated circuit device having sense amplifier, a data output buffer, and input/output
10 pads, the method comprising the steps of:
detecting a test mode in response to a logical states with external control signals of the integrated circuit device;
selecting a part of internal signals of the integrated circuit device in response to selection signals corresponding to test information signals;
15 selecting an alternative one of transfer paths of the part of the internal signals and output signals from the sense amplifier in response to the selection signals; and
transferring the part of the internal signals to an outside of the integrated circuit device through the data output buffer and the input/output
20 pads.

Abstract of the Disclosure

An integrated circuit device for testing is disclosed. The device
5 includes a plurality of internal circuits for generating a plurality of internal
signals, the internal signals used for addressing storage locations and for
controlling internal operations, a first selection circuit for receiving the
internal circuits in response to selection signals corresponding to test
information signals, a second selection circuit for receiving output signals
10 from the first selection circuit and output signals from a sense amplifier, and
for opening an alternative one of transfer paths of the internal signals and
the output signals in response to the selection signals, and a data output
buffer for transferring output signals from the second selection signals to an
outside of the device through data input/output pads.

Fig. 1

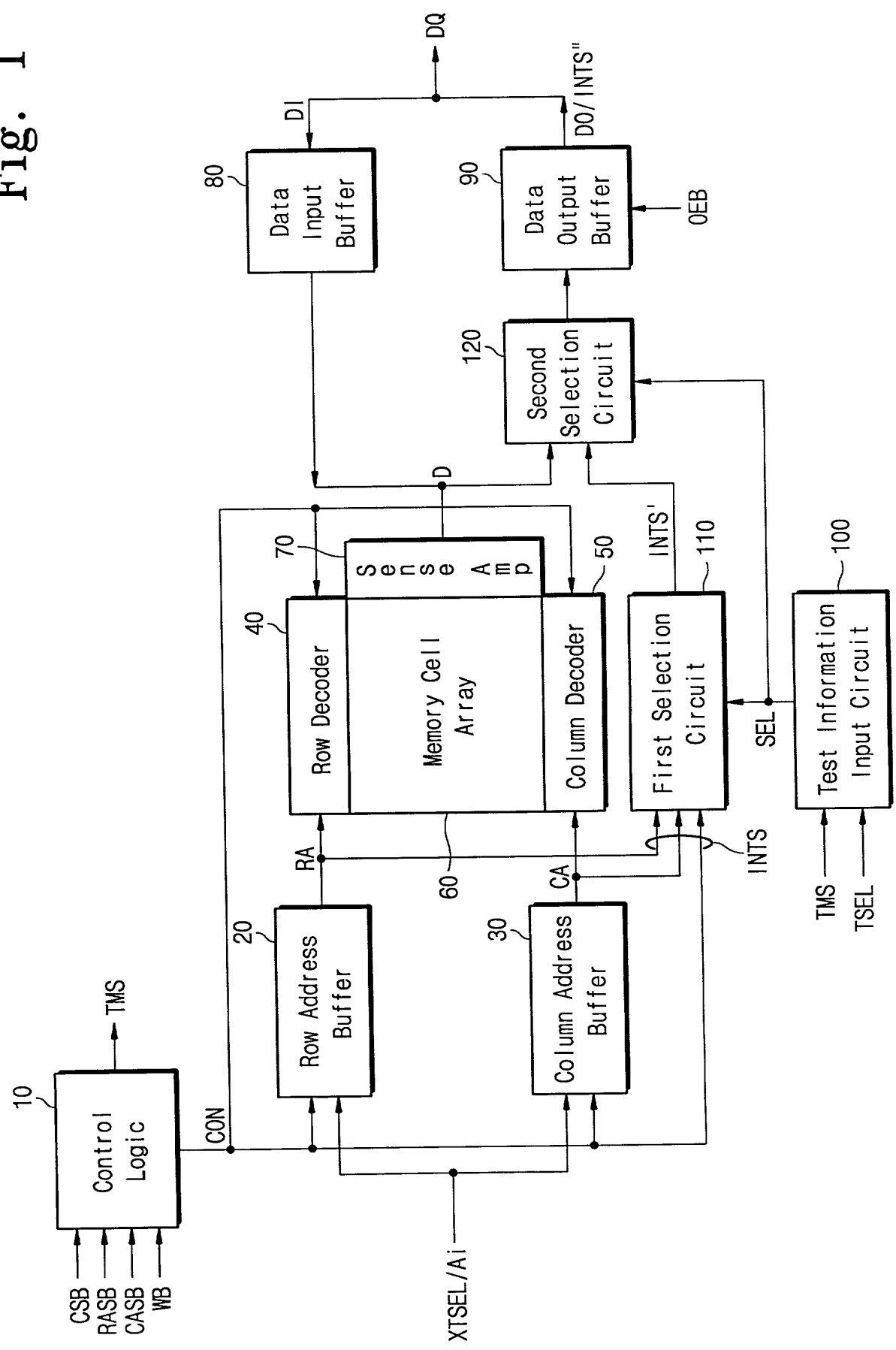


Fig. 3

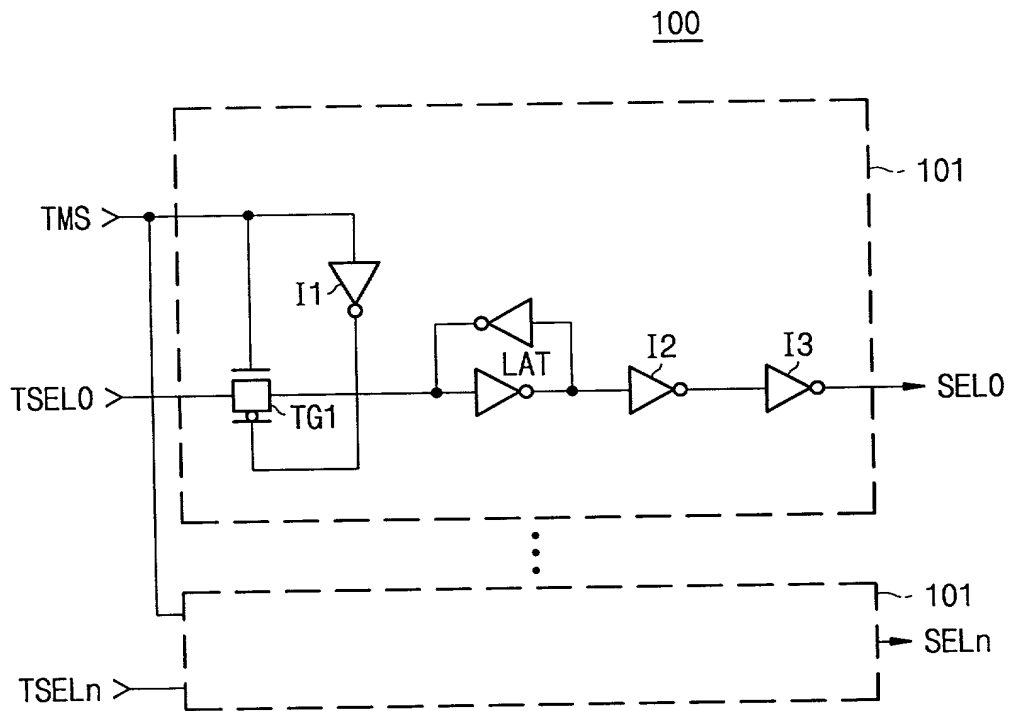


Fig. 4

111, 112, 113, 114

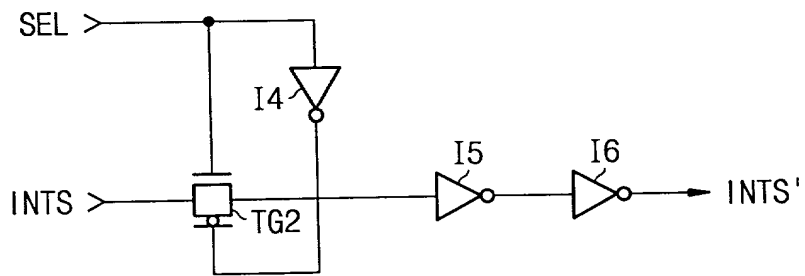


Fig. 5

121, 122, 123, 124

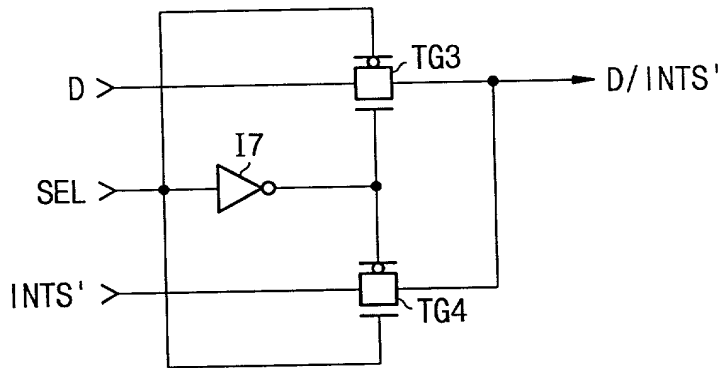


Fig. 6

91, 92, 93, 94

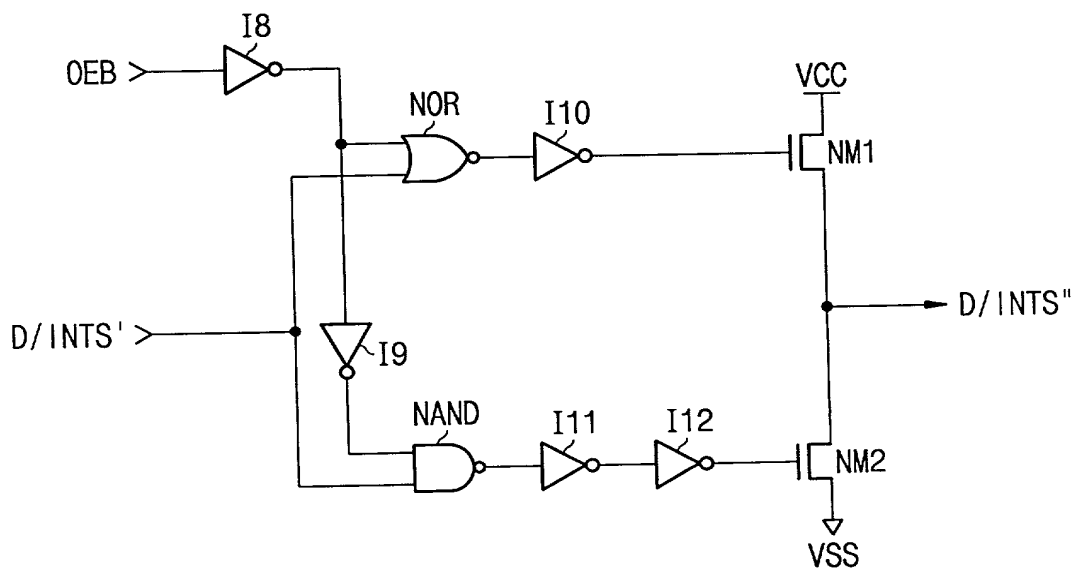
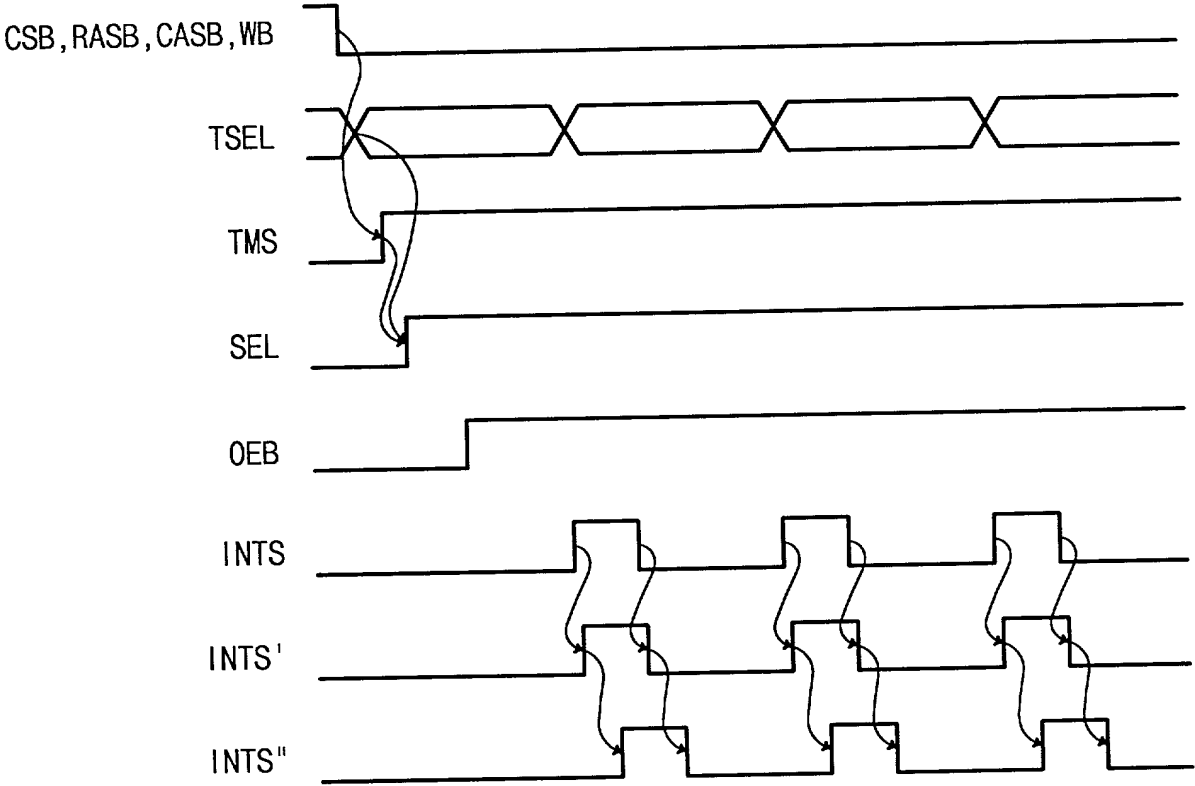


Fig. 7



**DECLARATION FOR PATENT APPLICATION
AND POWER OF ATTORNEY**

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below adjacent to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of subject matter (process, machine, manufacture, or composition of matter, or an improvement thereof) which is claimed and for which a patent is sought by way of the application entitled

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which (check) ☒ is attached hereto.
☐ and is amended by the Preliminary Amendment attached hereto.
☐ was filed on as Application Serial No.
☐ and was amended on (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information, which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, § 119(a)-(d) of any foreign application(s) for patent or inventor's certificate or any PCT international application(s) designating at least one country other than the United States of America listed below and have also identified below any foreign application(s) for patent or inventor's certificate or any PCT international application(s) designating at least one country other than the United States of America filed by me on the same subject matter having a filing date before that of the application(s) of which priority is claimed:

Prior Foreign Application(s)			Priority Claimed	
Number	Country	Day/Month/Year Filed	Yes	No
99-41360	Korea	September 27, 1999	<input checked="" type="checkbox"/>	<input type="checkbox"/>

I hereby appoint the following practitioners to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith:

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